

Form PTO-1449	US Dept. of Commerce PATENT & TRADEMARK OFFICE	ATTY DOCKET NO. A1145I	APPLICATION NO.
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)		APPLICANT Prosser et al	
		FILING DATE Herewith	GROUP ART UNIT

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	PUBLICATION DATE	NAME OF PATENTEE	CLASS	SUB CLASS
<i>SL</i>	1,959,154	5/15/34	Bremer		
<i>SL</i>	2,777,957	1/15/57	Walkup		
<i>SL</i>	2,965,754	12/20/60	Bickmore et al		
<i>SL</i>	3,888,578	6/10/75	Eto		
<i>SL</i>	3,937,960	2/10/76	Matsumoto et al		
<i>SL</i>	4,112,299	9/5/78	Davis		
<i>SL</i>	4,344,104	8/10/82	Habets et al		
<i>SL</i>	4,456,365	6/26/84	Yuasa		
<i>SL</i>	4,638,397	1/20/87	Foley		
<i>SL</i>	5,025,155	6/18/91	Hattori		
<i>SL</i>	5,324,942	6/28/94	Mishra et al		
<i>SL</i>	6,185,397	2/6/01	Kumar et al		
<i>SL</i>					

## FOREIGN PATENT DOCUMENTS

	COUNTRY	DOCUMENT NUMBER	PUBLICATION DATE	NAME OF PATENTEE OR APPLICANT	TRANSLATION Y/N
<i>SL</i>	EP	0 917 012	5/19/99	Xerox Corporation	Y
<i>SL</i>	EP	0 274 894	7/20/88	Xerox Corporation	Y

## OTHER DOCUMENTS (Including Author (in CAPS), Title, Publication Date, Pages, etc.)

<i>SL</i>	Xerox Disclosure Journal, Vol. 10, No. 3; May/June 1985; pgs. 139-140
<i>SL</i>	"The Negative Corona Current Distribution for a Long Pin-to-Plane Geometry," P.J. Walsh, et al, Photographic Science and Engineering, Vol. 28, No. 3, May/June 1984, pgs. 101-108
EXAMINER	<i>Huey M. Thomas</i> DATE CONSIDERED <i>10/28/05</i>
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	